

Gripper for transporting a vertically standing semiconductor wafer and method for cleaning the semiconductor wafer

Abstract

Gripper for transporting a vertically standing semiconductor wafer, comprising a flat body having a head section and a foot section, which form a planar front side; arms, which extend from the head section to spaced-apart ends in the foot section; at end sections of the arms, a supporting surface, which is set back from the plane of the front side; and holding pins, which are arranged on the end sections and are intended for establishing a clamping connection between the semiconductor wafer and the body, characterized by a channel which follows an inner side of the arms, is made in the arms and terminates at end edges, wherein the edges are separated from the ends of the arms.

Drawing relating to the abstract: Fig. 1